

# ERRORS AND TUNING PROCESS

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## A. Objectives

- Estimate the error tolerances of arc elements.
- Clarify the importance of the beam-based tuning process and its role in the tuning procedure.
  - > Guidelines for the development of beam-based measurement.

## B Simulations of tuning procedure

### 1. Effects considered

- Emittance ratio  
criterion :  $\varepsilon_y/\varepsilon_x < 2\%$
- Dynamic aperture  
criterion :
  - $2J_x/\varepsilon_x/1000 + 2J_z/\varepsilon_z/600 > 1$
  - ( $dp/p > 1.7\%$  with  $n_x=0$  and  $n_x > 32$  with  $dp/p = 0$ )
  - >  $\tau$  (Touchek)  $> 35000$  sec
- Miss-crossing at IP for field ripples.

Also  
 $2J_x > 1.2 \times 10^{-5}$   
 $dp/p > 0.3\%$   
 for injected beam

### 2. Errors and assumptions

- The magnitude of errors are given in Table -1.0 (static errors)

Table -1.0: Errors used in simulation<sup>1)</sup>

element	$\Delta x(\text{mm})$	$\Delta y(\text{mm})$	$\Delta\theta(\text{mrad})$	$\Delta k/k$
quads	0.15	0.15	0.2	$1 \times 10^{-3}$
quads(QC) <sup>2)</sup>	0.01	0.01	0.1	$1 \times 10^{-4}$
sexts	0.15	0.15	0.2	$2 \times 10^{-3}$
bends		0.1	0.1	$2 \times 10^{-3}$
correctors		0.1	0.2	
BPM <sup>3)</sup>	0.075	0.075		

<sup>1)</sup>The figures are for one standard deviation ( $\sigma$ ).

<sup>2)</sup> Two quads near IP(QCS and QC1).

<sup>3)</sup> Assume Beam-based measurement of BPM offset.

Table -1.1: Tolerance of field jitter

element	relative jitter ( $\sigma$ )	what limits
Bends	$1 \times 10^{-5}$	$\Delta x^* = 3.4\mu\text{m}$ ( $\sigma_x^* = 80\mu\text{m}$ )
Quads	$1 \times 10^{-4}$	$\epsilon_y/\epsilon_{y0} = 5 \pm 19\%$ $A/A_0 = 3 \pm 14\%$
Quads(QCS)	$1 \times 10^{-5}$	$\epsilon_y/\epsilon_{y0} = 10\%$ $A/A_0 = 10\%$
Sexts		
Correctors	$1 \times 10^{-5}$	$\Delta y^* = 0.1\mu\text{m}$ ( $\sigma_y^* = 2\mu\text{m}$ )

\* TRISTAN  
(2-3) $\times 10^{-5}$   
50Hz.

- Consider only LER. The situation of the HER is expected to be similar since its arc lattice is basically identical to that of LER.
- Errors of quads near the IP (QCS and QC1) are very small. This is to magnify the effects of errors in the arc section.
- Every sextupoles have a mover with a maximum stroke of 3 mm in both horizontal and vertical directions.
- Offset of BPMs relative to the magnetic center of quads are measurable with an accuracy of 75  $\mu\text{m}$  using beam-based method.
- Magnetic center of the sextupole is measurable with an accuracy of 75  $\mu\text{m}$  using beam-based method.
- Strength errors of quads are measurable with an accuracy of 0.1% using direct or beam-based measurement.
- The errors obey Gaussian distribution with cut-off at 3 standard deviations ( $3\sigma$ ).

### 3. Simulation results

#### 3.1 Static errors

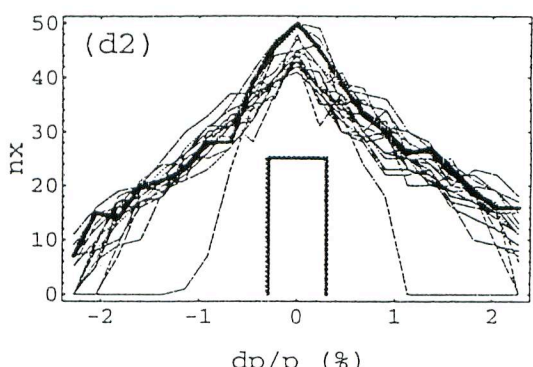
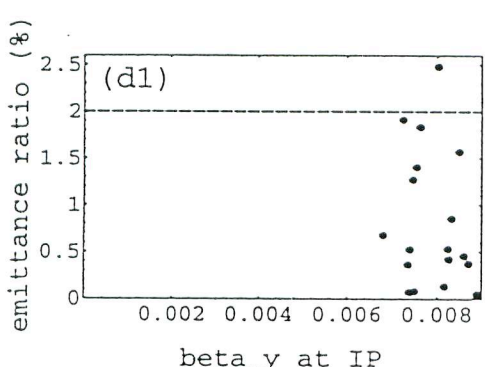
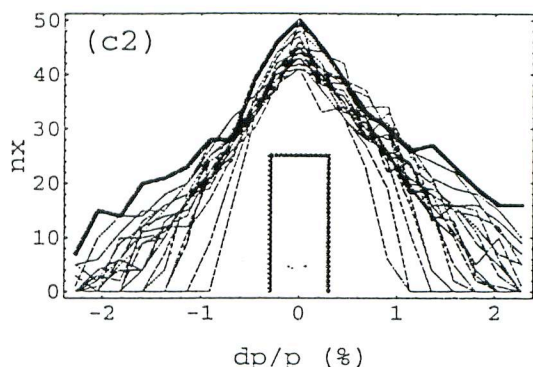
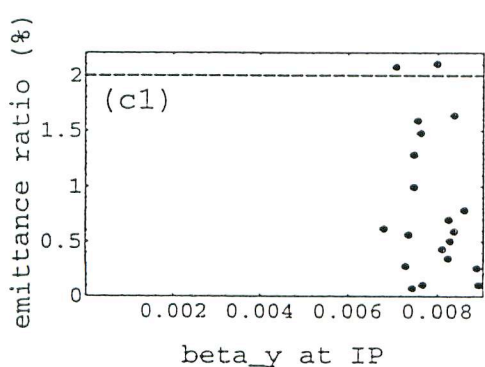
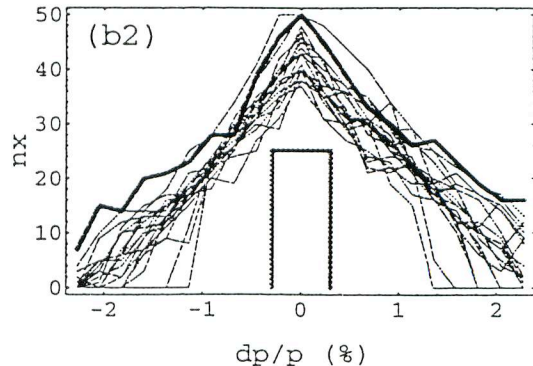
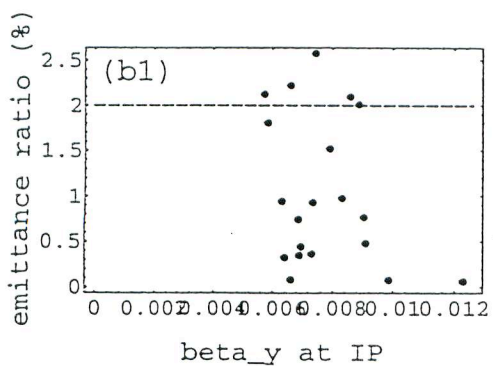
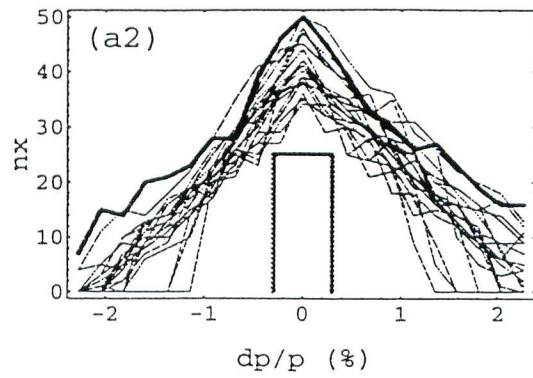
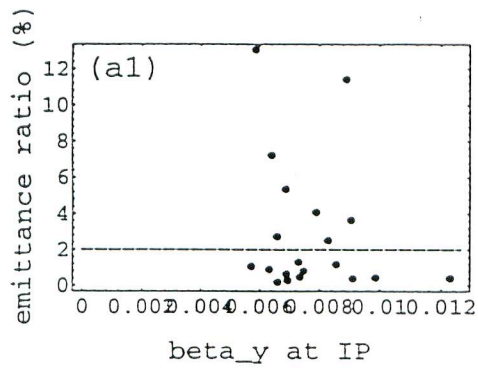
- Simulations with 20 different random seeds.

$(v_x, v_y) = (46.52, 46.08)$

initial conditions:  $2J_x = n_x^2 \epsilon_{x0}$

$2J_y = 0.11^* 2J_x$

$dp/p = -2 \sim +2\%$





- ! Sextupole re-alignment is very effective to improve the vertical emittance.
- ! The ordinary orbit correction and the sextupole re-alignment are sufficient in almost all the cases to fulfill the requirements.
- ! Measurement of the field error of quads with an accuracy of 0.1% is important for precise optics tuning.

### 3.2 Field ripples

Field ripples with a frequency for which the orbit feedback does not work may degrade the performance..

- Criteria:

- Emittance growth and deterioration of dynamic aperture are less than 10%
- Deviation of beam position at IP does not exceed  $0.1\sigma^*_{x,y}$

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## D Summary

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### static errors

- Required emittance ratio and the dynamic aperture is achievable under the errors given in Table -1.0 if the sextupole has a mover and assumed beam-based measurement technique is available.
- Sextupole re-alignment is very effective to improve the vertical emittance.
- Measurement of the field error of quads with an accuracy of 0.1% is important for precise optics tuning.

### Field ripples

- Tolerance of field ripples was estimated.

### Beam-based measurement

- beam-based measurement should be developed.